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Attorney's Docket No.: 042390P13229D

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Andideh, Ebrahim

U.S. Serial No: 10/662,094

Filed: September 12, 2003

For: A METHOD OF FORMING A
LOW-DIELECTRIC CONSTANT
STRUCTURE WITH A MULTILAYER
STACK OF THIN FILMS WITH PORES
(as amended)

Examiner: Erdem, Fazli

Art Unit: 2826

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed June 4, 2004. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

on October 26, 2004

Date of Deposit

Teresa Mattox

Name of Person Mailing Correspondence

Teresa Mattox
Signature

October 26, 2004
Date

Serial No. 10/662,094

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